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Washington, D.C. 20231

**SERIAL NO. 10/670,836**

DOCKET NO. AUS920030791US1

DATE: July 16, 2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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/Leslie A. Van Leeuwen, Reg. No. 42,196/  
Leslie A. Van Leeuwen, Reg. No. 42,196

July 16, 2007  
Date

Sir:

Transmitted herewith for filing is the Patent Application of:

Inventors: Aguilar, et al.

For: System and Method for Processor Dedicated Code Handling in a Multi-Processor Environment

Enclosed are:

- Information Disclosure Statement;
- Modified form 1449 listing 11 references;
- copies of any non-U.S. Patent references listed on form 1449.
- The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 09-0447.
- Any additional patent application processing fees under 37 CFR Sect. 1.17.

Respectfully submitted,

By /Leslie A. Van Leeuwen, Reg. No. 42,196/  
Leslie A. Van Leeuwen, Reg. No. 42,196  
Attorney for Applicant  
Telephone: (512) 301-6738  
Facsimile: (512) 301-6742

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re application of:** § **Group Art Unit: 2193**  
**Aguilar, et. al.** §  
**Serial No.: 10/670,836** §  
**Filed: September 25, 2003** §  
**Title: System and Method for Processor** § **Intellectual Property Law Dept.**  
**Dedicated Code Handling in a Multi-** § **11400 Burnet Road**  
**Processor Environment** § **Austin, Texas 78758**

**INFORMATION DISCLOSURE STATEMENT**

The Commissioner of Patents  
Washington, D.C. 20231

Sir:

Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While this Information Disclosure Statement may be "material" pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to herein is "prior art" for this invention unless specifically designated as such. In accordance with 37 CFR § 1.97(g) the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR § 1.56 (a) exists.

The attached form, PTO-1449, provides a listing of patents, publications, or other information as required by 37 CFR § 1.98 (a)(1). A copy of each listed item that is not a U.S. Patent document, is supplied herewith.

37 CFR § 1.97 is satisfied by the following:

X This IDS is being filed pursuant to CFR § 1.97(c) and:

X no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in § 1.56(c) more than three months prior to the filing of the information disclosure statement.

Respectfully submitted,

By Leslie A. Van Leeuwen, Reg. No. 42,196  
Leslie A. Van Leeuwen, Reg. No. 42,196  
**Van Leeuwen & Van Leeuwen**  
Attorneys for Applicant  
Telephone: (512) 301-6738  
Facsimile: (512) 301-6742

In Place of FORM PTO-1449 (Modified)

Serial No. **10/670,836**

Applicant: **Aguilar**

Filing Date: **9/25/2003**

Group: 2193

Atty. Docket No. **AUS920030791US1**

**LIST OF PATENTS AND PUBLICATIONS FOR  
APPLICANT'S INFORMATION DISCLOSURE  
STATEMENT**

**U. S. PATENT DOCUMENTS**

Examiner <u>Initial</u>	Document <u>Number</u>	Date	Name	Classification <u>Class / Subclass</u>	Filing Date if <u>Appropriate</u>
_____	AA 7,143,419	11-2006	Fischer et al.	719/328	
_____	AB 6,446,218	09-2002	D'Souza	714/4	
_____	AC 2005/0081187	04-2005	Odinak et al.	717/101	
_____	AD 2004/0181785	09-2004	Zwirner et al.	717/140	
_____	AE 5,307,495	04-1994	Seino et al.	718/106	
_____	AF 6,981,072	12-2005	Day et al.	710/22	
_____	AG 7,167,916	01-2007	Willen et al.	709/226	
_____	AH 2003/0045612	03-2003	Misura et al.	523/456	
_____	AI 7,043,579	05-2006	Dhong et al.	710/107	
_____	AJ 5,630,128	05-1997	Farrell et al.	718/103	

**FOREIGN PATENT DOCUMENTS**

Examiner <u>Initial</u>	Document <u>Number</u>	Date	Country	Classification	Translation <u>Yes</u> <u>No</u>
_____	AK				
_____	AL				

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

_____	AM	Oram et al., "Managing Projects with make," O'Reilly & Associates, Inc., ISBN 0-937175-90-0, October 1995, pp. 78-80.
_____	AN	
_____	AO	
_____	AP	

Examiner: \_\_\_\_\_ Date Considered: \_\_\_\_\_

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.